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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Jae Han CHA

ART UNIT: 2823

SERIAL NO.: 10/612,074

EXAMINER: Estrada, Michelle

FILING DATE: July 3, 2003

FOR: METHOD OF FORMING AN ISOLATION FILM IN A SEMICONDUCTOR
DEVICE

CHANGE OF ADDRESS

September 23, 2004

ASSISTANT COMMISSIONER FOR PATENTS
PO BOX 1450
ALEXANDRIA, VA 22313-1450
SIR:

Please take note of the following change of address. All correspondence related to the
above-captioned matter should now be directed to:

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Respectfully submitted,

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